

10997 U.S. PTO
10/005347
12/07/01

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

| | | | | | |
|---|---------------------------|---|----------|------------------------------------|----------|
| APPL NUM 10005347 | FILING DATE 12/07/2001 | CLASS 524 | SUBCLASS | GAU 1712 | EXAMINER |
| **APPLICANTS: Kozawa Miwa; Watanabe Keiji; Yano Ei; | | | | | |
| **CONTINUING DATA VERIFIED: yes THIS APPLICATION IS A DIV OF 09/553,479 04/20/2000 PAT 6,342,562 Kij | | | | | |
| ** FOREIGN APPLICATIONS VERIFIED: yes JAPAN 11-116517 04/23/1999 JAPAN 2000-000000 03/23 2000 Kij | | | | | |
| PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/> | | RESCIND <input type="checkbox"/> | | | |
| Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no | | 35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no | | ATTORNEY DOCKET NO 100021-00065 | |
| Verified and Acknowledged Examiners's initials Kij | | | | | |
| TITLE : Silicon-containing polymer, process for its production, resist composition employing it, pattern-forming method and electronic device fabrication method | | | | | |

| | | | |
|---|-----------|-----------------------------|------------------------------|
| NOTICE OF ALLOWANCE MAILED | | CLAIMS ALLOWED | |
| | | Total Claims 5 | Print Claim for O.G. 1, 3 |
| ISSUE FEE | | DRAWING | |
| Amount Due | Date Paid | Sheets Drwg. 1 | Figs.Drwg. 3 |
| | | Print Fig. — | |
| <input type="checkbox"/> TERMINAL DISCLAIMER | | Primary Examiner | |
| | | PREPARED FOR ISSUE | |
| | | Application Examiner | |
| WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only. | | | |

FILED WITH: ☐ DISK (CRF) ☐ CD-ROM
(Attached in pocket on right inside flap)